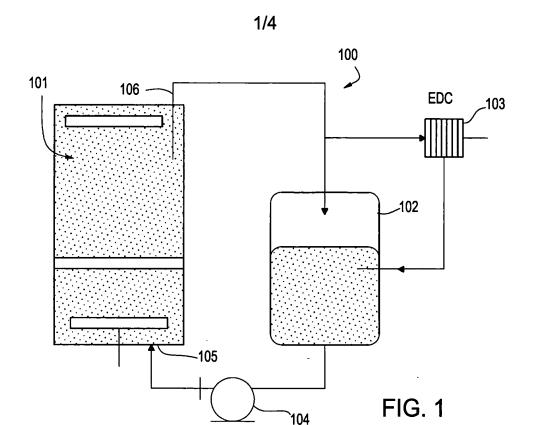
ATTY DKT. NO.: U.S. SERIAL NO.: FILED: APPLICANT: TITLE:

INVENTOR:

REPLACEMENT SHEET

AMAT/6394/PPC/ECP/RKK
10/074,569 CONFIRMATION: 1753
February 11, 2002
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Apparatus and Method for Removing Contaminants from Semiconductor Copper Electroplating Baths
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SHEET 1 OF 4



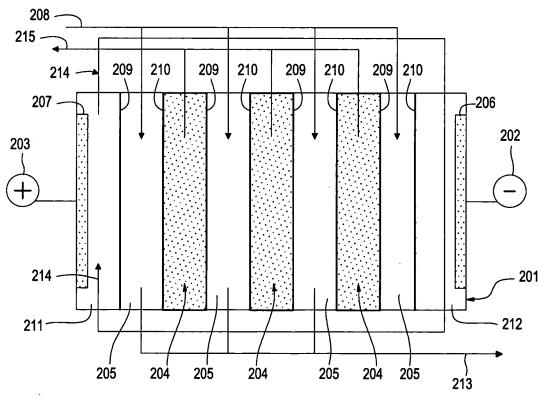


FIG. 2

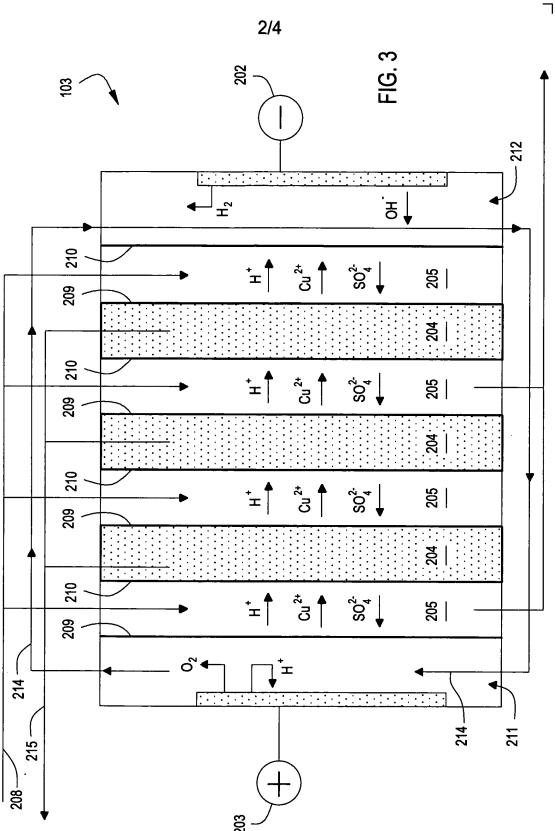
ATTY DKT. NO.: U.S. SERIAL NO.: FILED:

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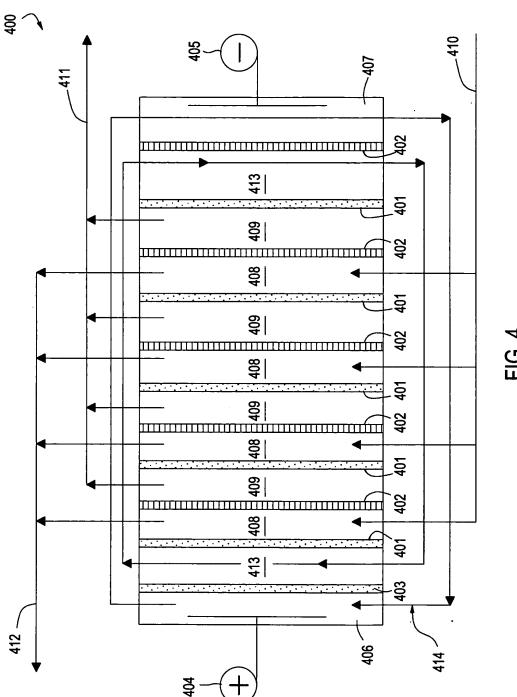
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